

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Jarmo Ilmari Maula et al.

Confirmation No. 6735

Application No. 10/609,136

Filed: June 26, 2003

RECEIVED
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DEC 06 2004For: **DIAPHRAGM VALVE FOR
HIGH-TEMPERATURE PRECURSOR
SUPPLY IN ATOMIC LAYER DEPOSITION**

Group Art Unit: 3754

Examiner: Kevin L. Lee

Date: December 6, 2004

PETITION FOR EXTENSION OF TIME UNDER 37 CFR § 1.136(a)

TO THE COMMISSIONER FOR PATENTS:

Applicant's attorney hereby petitions that the time for response to the September 3, 2004 Office Action, having a December 3, 2004 expiration date, be extended for a period of one month to January 3, 2005.

Please charge the extension fee of \$55.00 to Deposit Account No. 19-4455. The Commissioner is hereby authorized to charge any additional fees which may be required in connection with filing of these papers, or credit any overpayment to Account No. 19-4455.

Respectfully submitted,

Planar Systems, Inc.

By



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